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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:	)
Li-Shun Wang, John Chu	Examiner: Garcia, Joannie A
Application No.: 09/476,633	) Art Unit: 2823
Filed: December 31, 1999	Confirmation No.: 8091
For: REMOVAL OF RESIDUE FROM A SUBSTRATE	) ) )

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## **PRELIMINARY AMENDMENT**

In connection with the filing of a Request for Continued Examination, Applicants respectfully request entry of the amendments set forth below and consideration of the remarks that follow.